PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazunori ANAZAWA et al.

Application No.: New U.S. Patent Application

Filed: June 23, 2003 Docket No.: 116316

For: MANUFACTURING APPARATUS AND METHOD FOR CARBON NANOTUBE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the reference 2 is discussed in the present specification.

Respectfully submitted,

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JAO:JSA/mlb Date: June 23, 2003

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(Use several sheets if necessary)		APPLICANTS Kazunori ANAZAWA et al.					
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FOREIG	N PATENT D	OCUMENTS		<u> </u>			
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OTHER DOCUMENTS (Incl.	uding Author	Title, Date, Pertinent Pages, e	tc.)	.±., .			
Anazawa et al., High-purity carbon nane Letters, Vol. 81, No. 4, pp. 739-741, 20	otubes synthe	sis method by an arc discharging	ng in magnetic	field", Appli	ed Physics		
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EXAMINER DATE CONSIDERED							
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 23, 2003